

Form PTO-1449

# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)  
2919.5US (96-499.2)

Application Number  
Not Yet Assigned

Applicant Pal-Hung Pan

09/944506

Filing Date August 30, 2001

Group Art Unit Unknown

10/30/01

08/30/01

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
G	4,307,180	12/1981	Pogge			
G	4,786,954	11/1988	Morie et al.			
G	4,849,344	07/1989	Desbiens et al.			
G	5,173,439	12/1992	Dash et al.			
G	5,272,117	12/1993	Roth et al.			
G	5,296,392	03/1994	Gula et al.			
G	5,297,082	03/1994	Lee			
G	5,346,587	09/1994	Doan et al.			
G	5,433,794	07/1995	Fazan et al.			
G	5,436,488	07/1995	Poon et al.			
G	5,459,096	10/1995	Venkatesan et al.			
G	5,492,858	02/1996	Bose et al.			

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

G		Davari, et al., "A Variable-Size Shallow Trench Isolation (STI) Technology With Diffused Sidewall Doping For Submicron CMOS", <i>IEEE IEDM</i> (1988).
G		K. Blumenstock et al., "Shallow Trench Isolation for Ultra-Large-Scale Integrated Devices", <i>J. Vac. Sci. Technol.</i> , B 12(1) (Jan/Feb 1994).

EXAMINER

Fowleson

DATE CONSIDERED

7/15/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

<b>Form PTO-1449</b> <b>INFORMATION DISCLOSURE CITATION</b> <b>IN AN APPLICATION</b> (Use several sheets if necessary)		Docket Number (Optional) <b>2919.5US (96-499.2)</b> Applicant <b>Pai-Hung Pan</b> Filing Date <b>August 30, 2001</b>		Application Number <b>Not Yet Assigned</b> <b>09/944506</b> <b>2823</b> Group Art Unit <b>Unknown</b>	
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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>CF</i>	5,506,168	04/1996	Morita et al.			
<i>CF</i>	5,516,625	05/1996	McNamara et al.			
<i>CF</i>	5,516,721	05/1996	Galli et al.			
<i>CF</i>	5,521,422	05/1996	Mandelman et al.			
<i>CF</i>	5,677,233	10/1997	Abiko			
<i>CF</i>	5,683,932	11/1997	Bashir et al.			
<i>CF</i>	5,712,185	01/1998	Tsai et al.			
<i>CF</i>	5,801,083	09/1998	Yu et al.			
<i>CF</i>	5,811,346	09/1998	Sur et al.			
<i>CF</i>	5,834,358	11/1998	Pan et al.			
<i>CF</i>	5,960,297	09/1999	Saki			

  

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

  

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)

  

EXAMINER <i>FOURSON</i>	DATE CONSIDERED <i>7/15/04</i>
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